



500.42846X00 *146*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): M. Hasegawa, et al.

Application No.: 10/628,275

Filed: July 29, 2003

Title: STAMPER, LITHOGRAPHIC METHOD OF USING THE STAMPER AND METHOD OF FORMING A STRUCTURE BY A LITHOGRAPHIC PATTERN

Group: 1733

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §1.97 AND §1.98**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 13, 2005

Sir:

Pursuant to Applicants' duty of disclosure, enclosed please find a Partial European Search Report, and copies of documents cited therein, in connection with an European patent application corresponding to the above-identified application. Also enclosed is a Form PTO/SB/08A, listing the enclosed documents.

This Information Disclosure Statement is being submitted prior to a first Office Action on the merits in the above-identified application. Accordingly, requirements of 37 CFR § 1.97(b) are satisfied.

In any event, the following Statement is made under 37 CFR § 1.97(e):

Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 CFR § 1.97 and § 1.98 have been satisfied, in connection with present submission of the documents listed on the enclosed Form. Accordingly, consideration of the listed documents, upon examination of the above-identified application, is respectfully requested.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Deposit Account No. 01-2135 (Case No. 500.42846X00), and please credit any excess fees to such Deposit Account.

Respectfully submitted,

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <small>(use as many sheets as necessary)</small>				Complete if Known	
				Application Number	10/628,275
				Filing Date	7/29/2003
				First Named Inventor	M. Hasegawa
				Art Unit	1733
				Examiner Name	TBD
Sheet	1	of	1	Attorney Docket Number	500.42846X00

U.S. PATENT DOCUMENTS						
Examiner Initials'	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)				
		US- 6,350,360		2/26/2002	Bonivert, et al.	
		US- 6,306,547		10/23/2001	Kobayashi	
		US- 6,127,263		10/3/2000	Parikh	
		US- 5,789,117		8/4/1998	Chen	
		US- 5,817,242		10/6/1998	Biebuyck, et al.	
		US- 6,190,809		2/20/2001	Tzu, et al.	

FOREIGN PATENT DOCUMENTS							
Examiner Initials'	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)					
		EP 1 376 663		1/2/2004	Hewlett-Packard Development Company, L.P.		

NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					T ²
		Communication and Partial European Search Report issued October 15, 2004, for No. EP 03 01 6539					
		Li, et al., "Direct three-dimensional patterning using nanoimprint lithography", Applied Physics Letters. Vol. 78, No. 21, May 21, 2001, pages 3322-4					
Examiner Signature		Date Considered					

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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